

L Number	Hits	Search Text	DB	Time stamp
1	177	cvd adj3 silicon adj3 carbide	USPAT	2003/05/27 11:27
2	0	(cvd adj3 silicon adj3 carbide) and plasma adj3 etch?	USPAT	2003/05/27 11:28
3	85	(cvd adj3 silicon adj3 carbide) and plasma	USPAT	2003/05/27 11:28
4	33	((cvd adj3 silicon adj3 carbide) and plasma ) and hydrogen	USPAT	2003/05/27 11:28